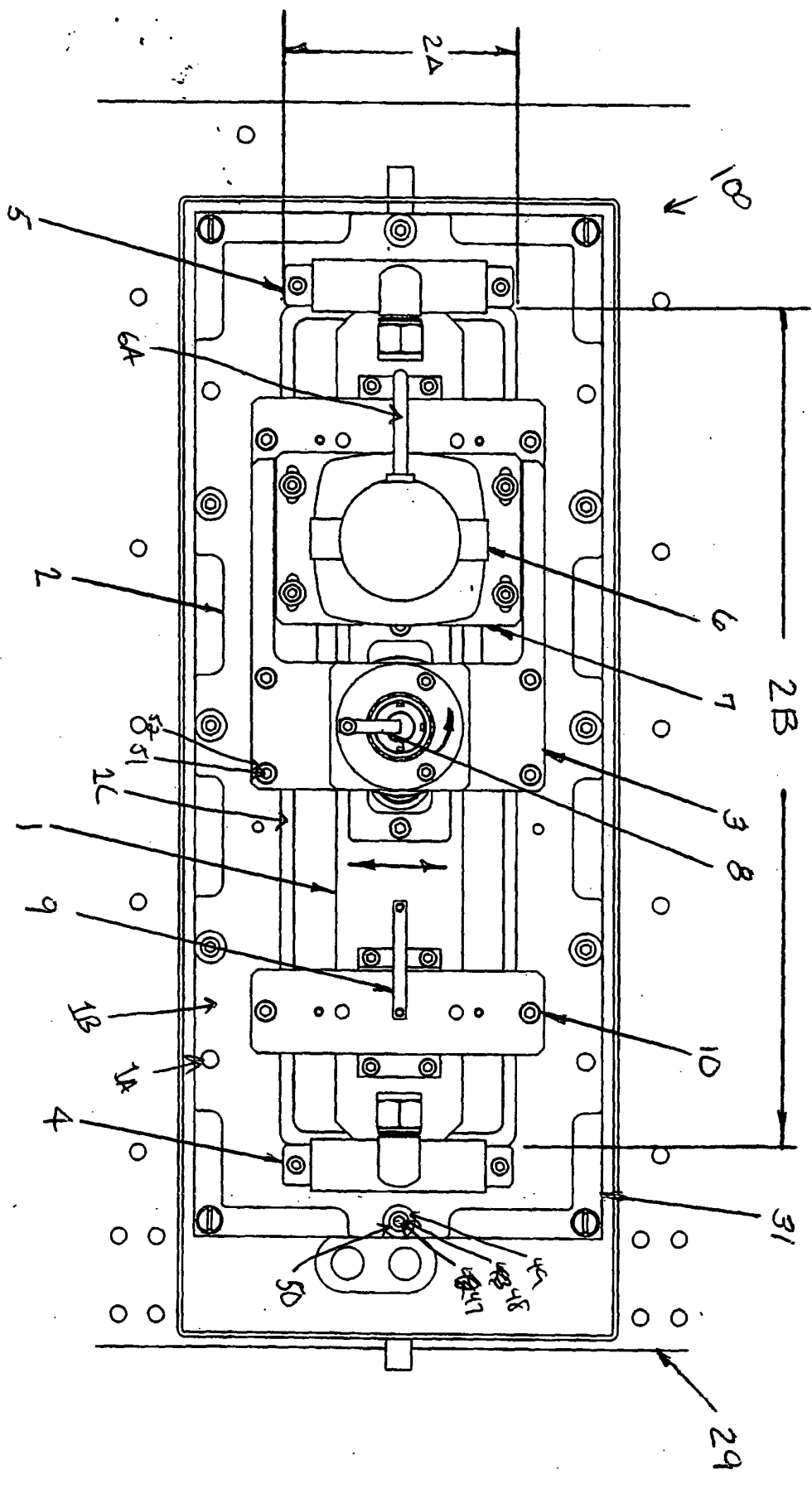


FIG 1
TOP VIEW



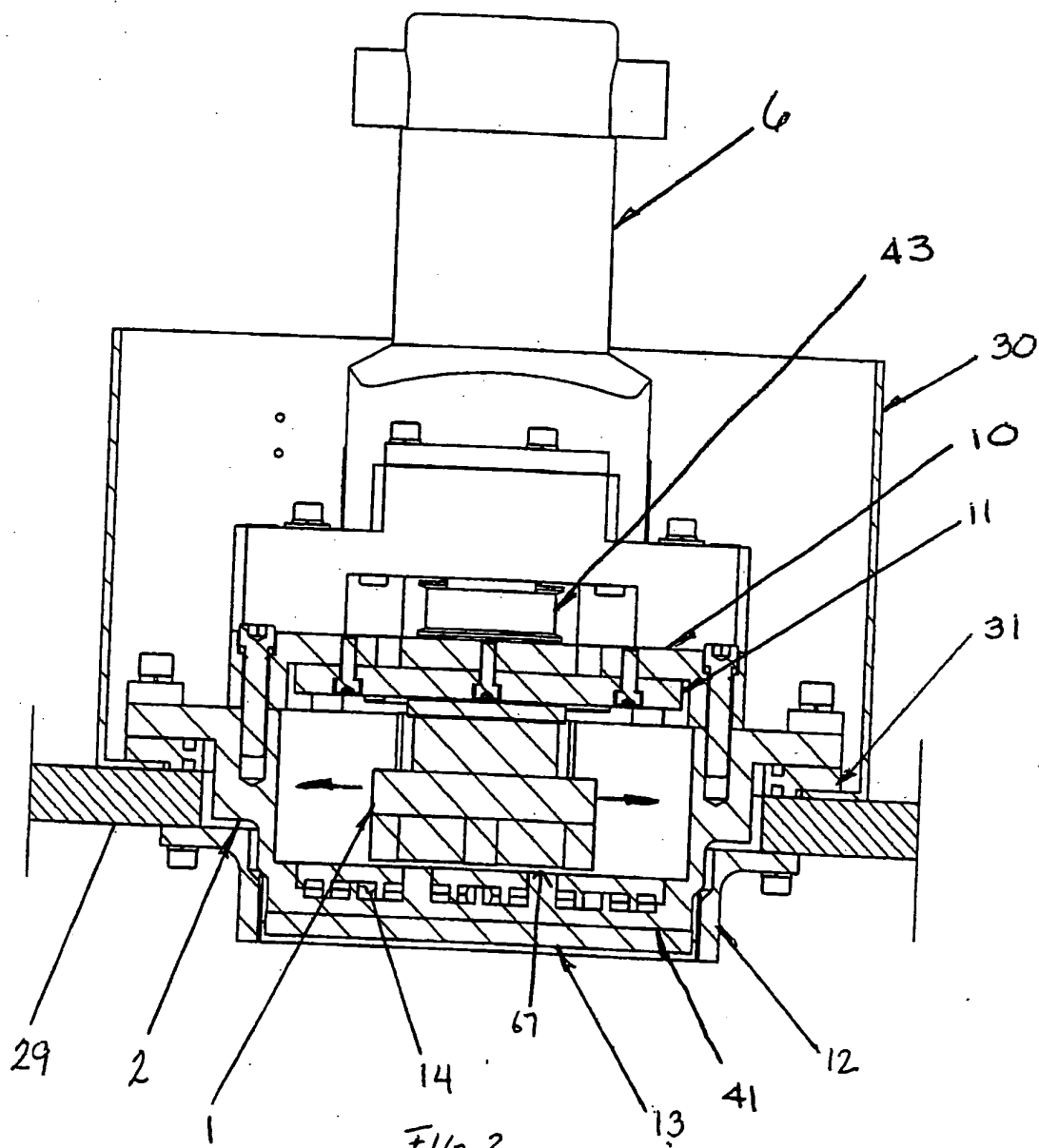


FIG 2

END VIEW

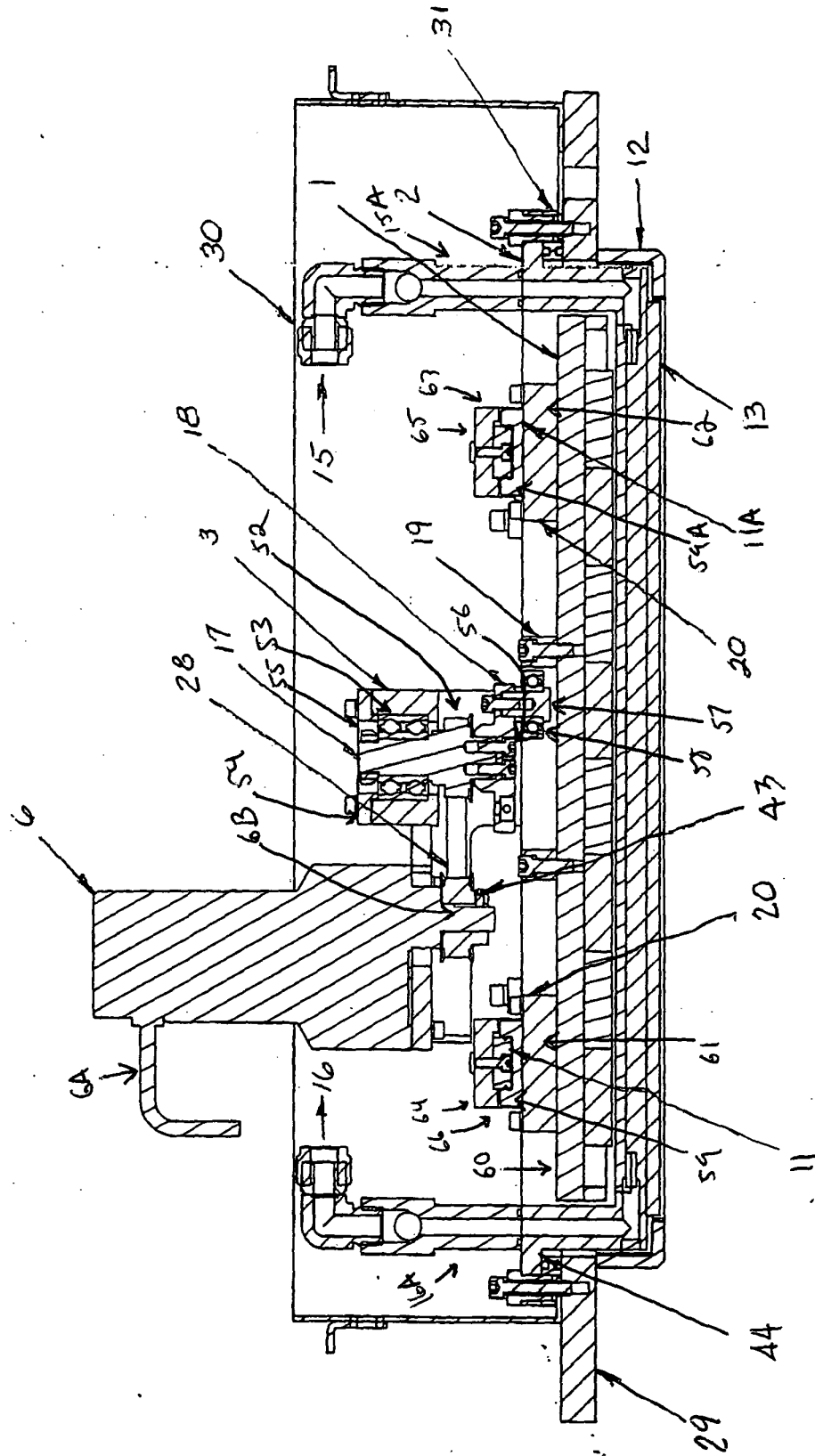
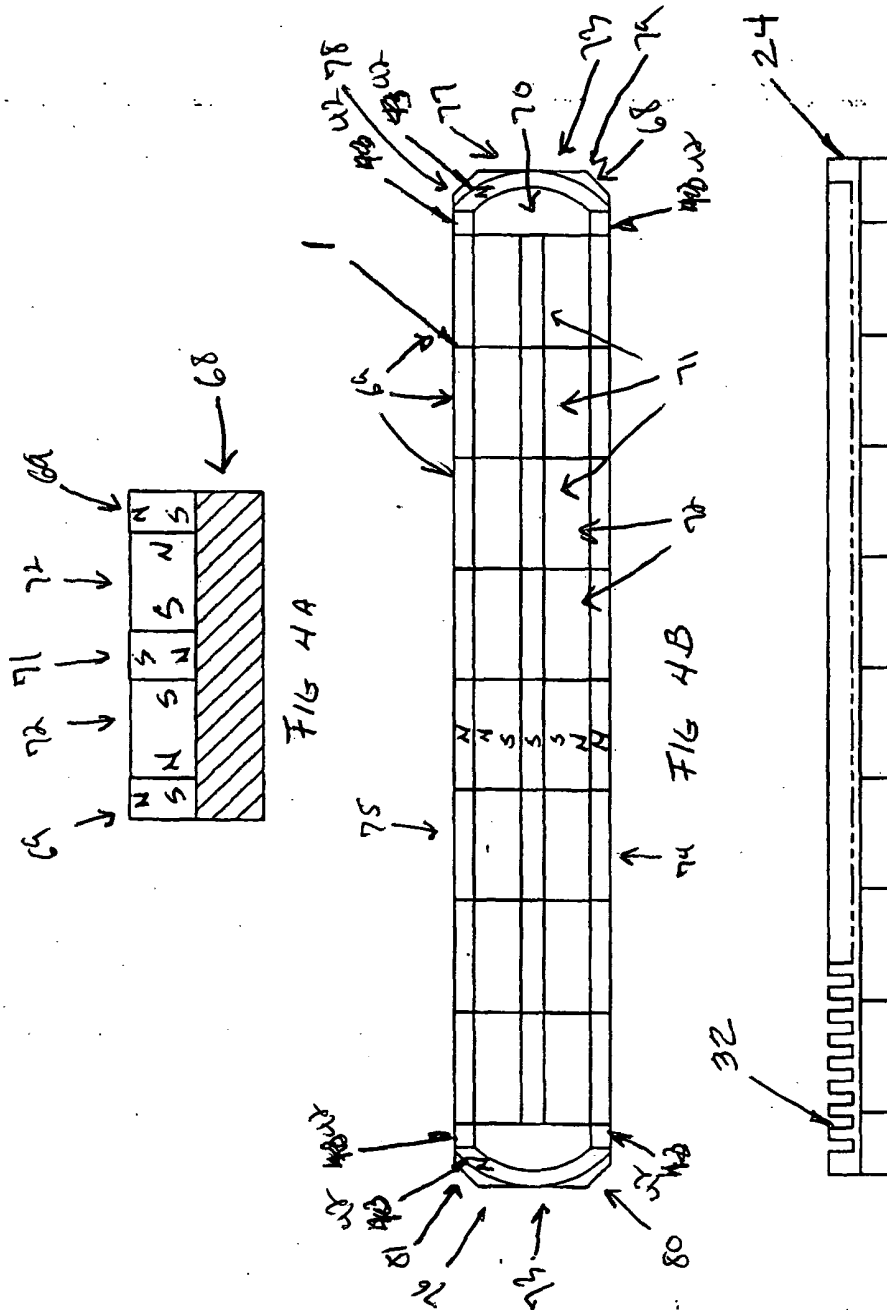


FIG 3



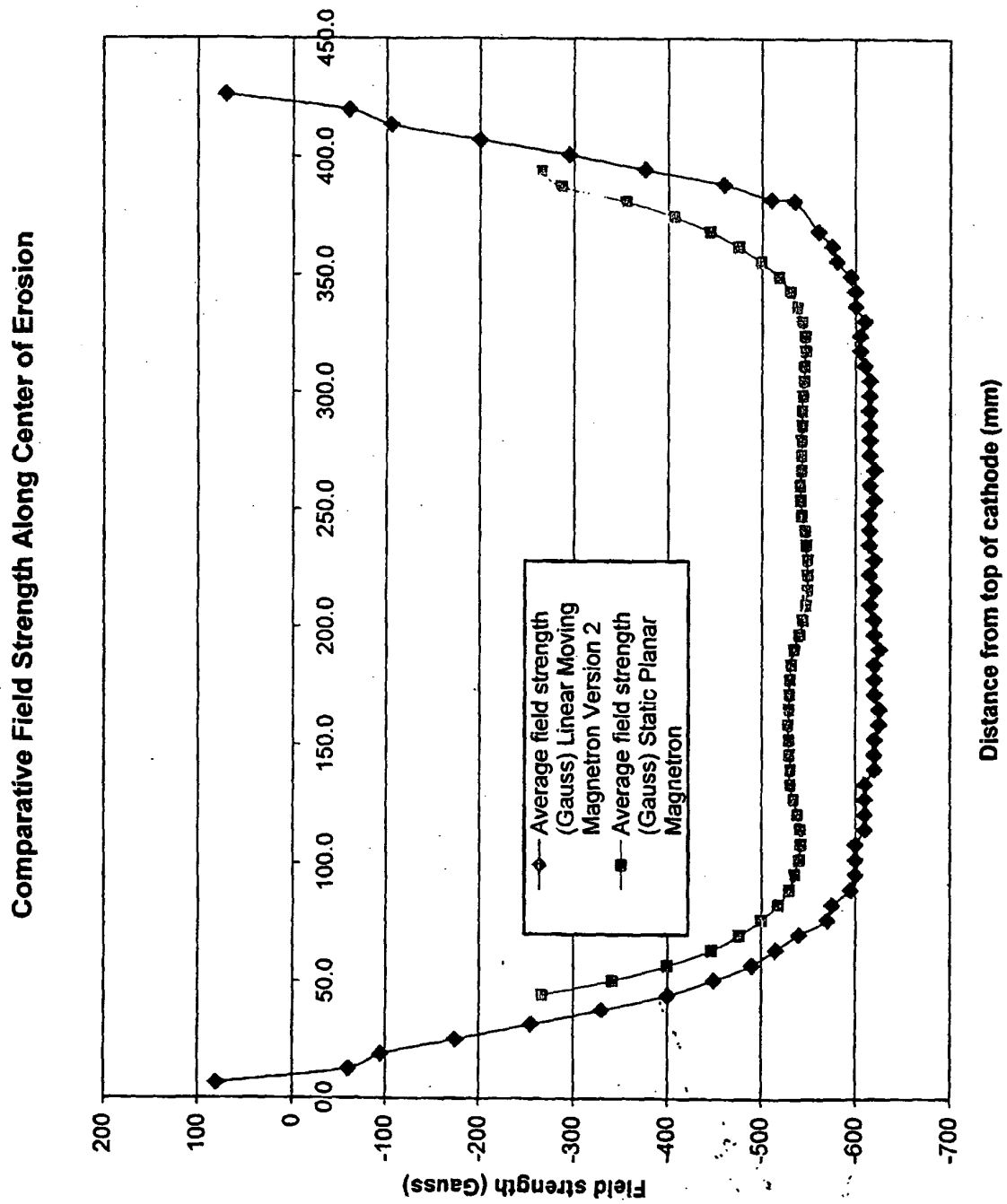


Figure 5.

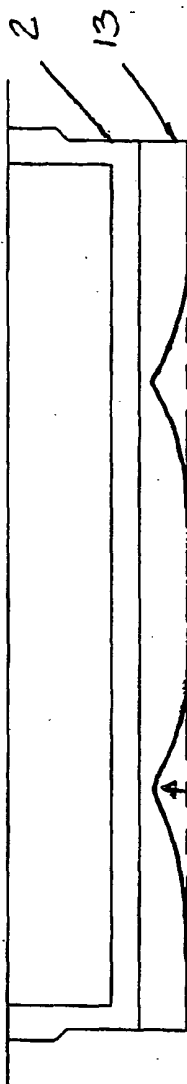


FIG 5A
PRIOR ART

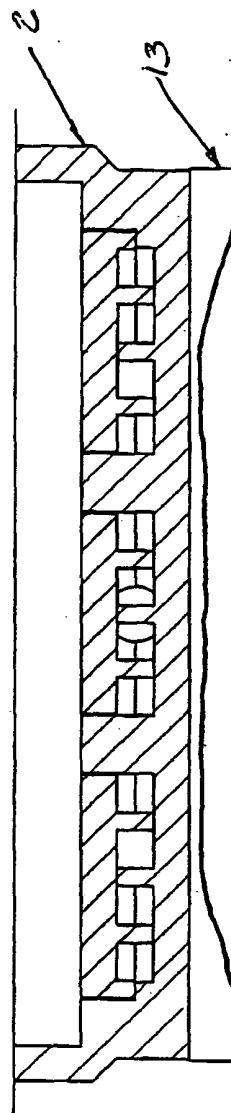


FIG 5B

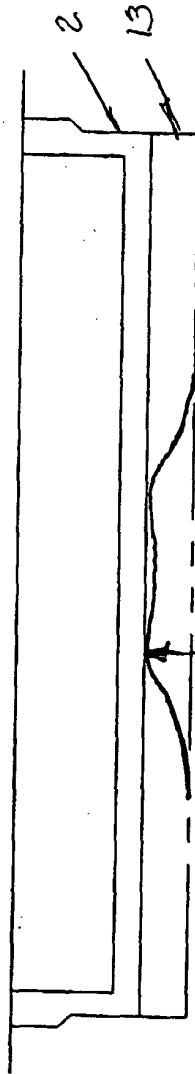


FIG 7A
PRIOR ART

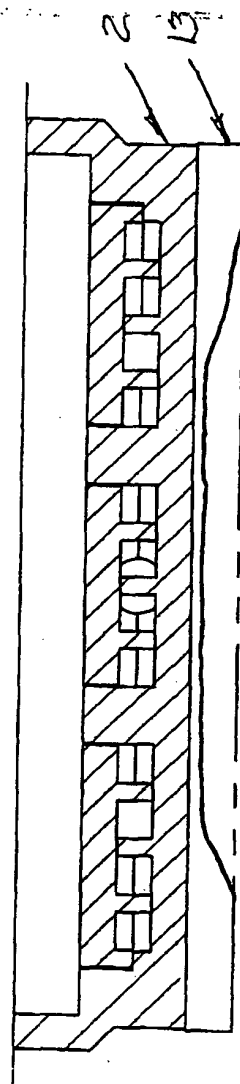


FIG 7B

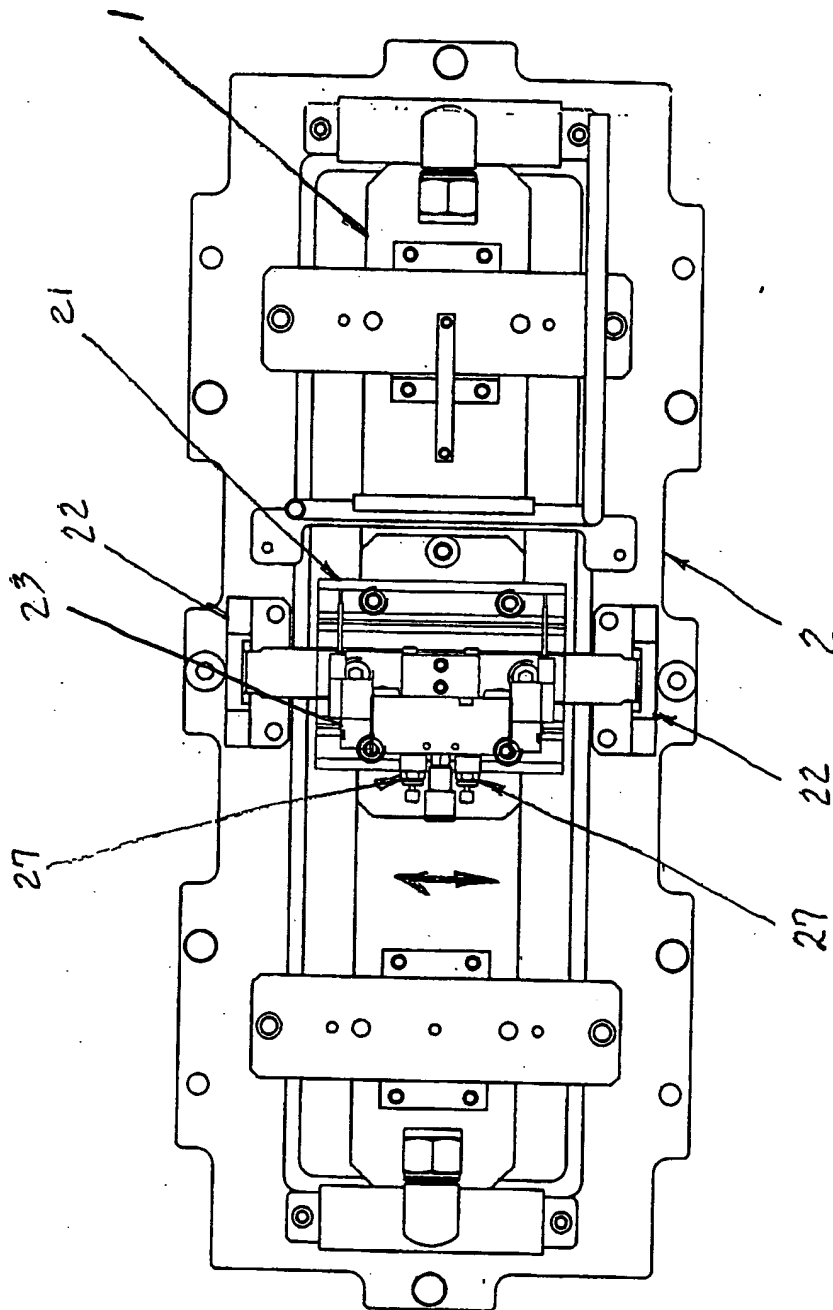
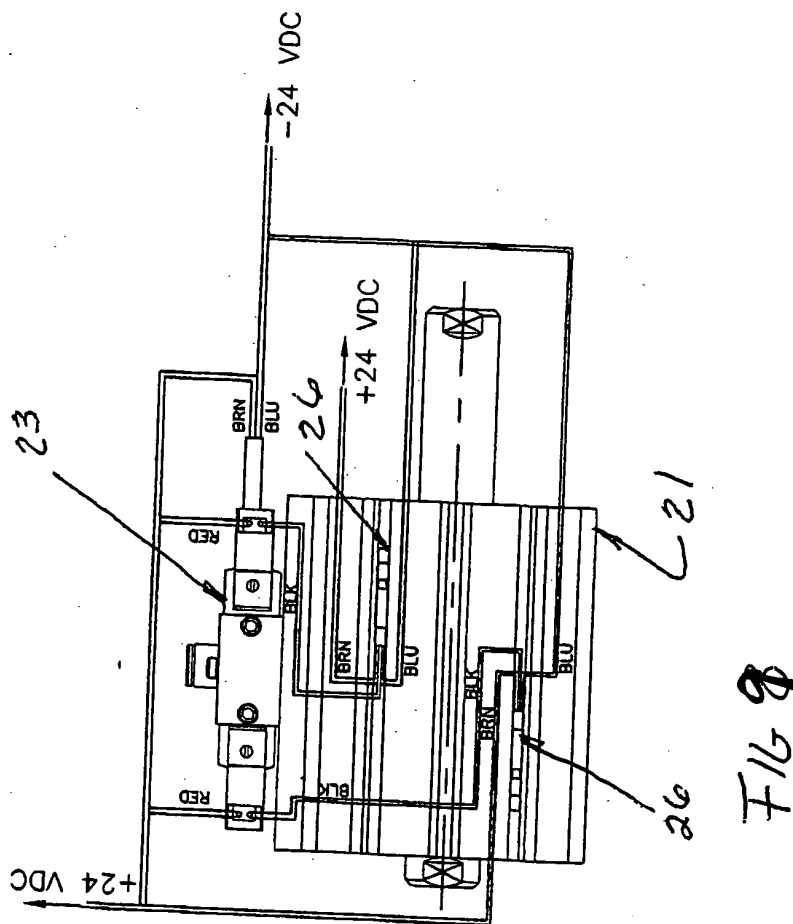


Fig 8



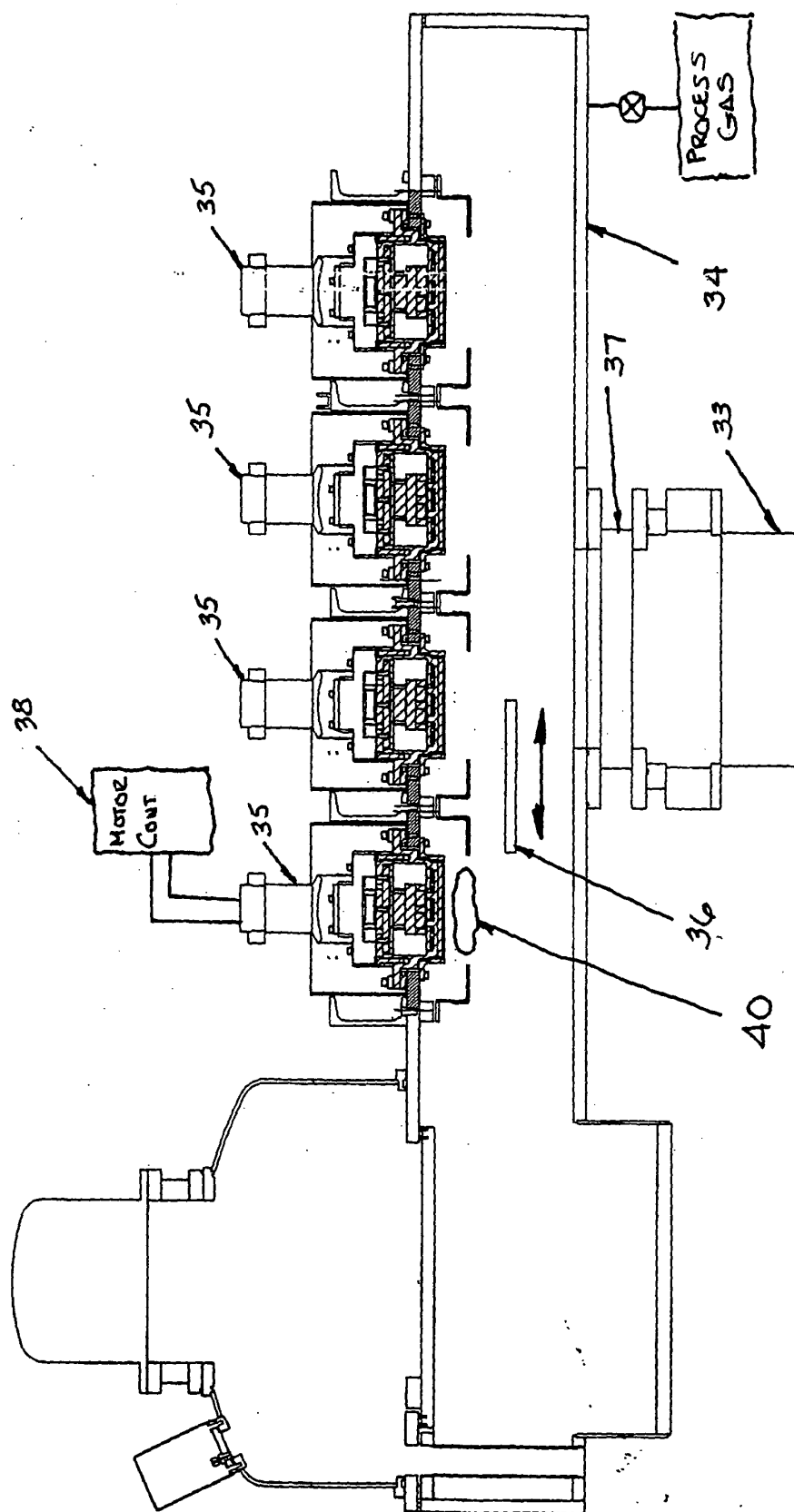


FIG 10

Aluminum thickness profile top-to-bottom
LMM cathode version 3

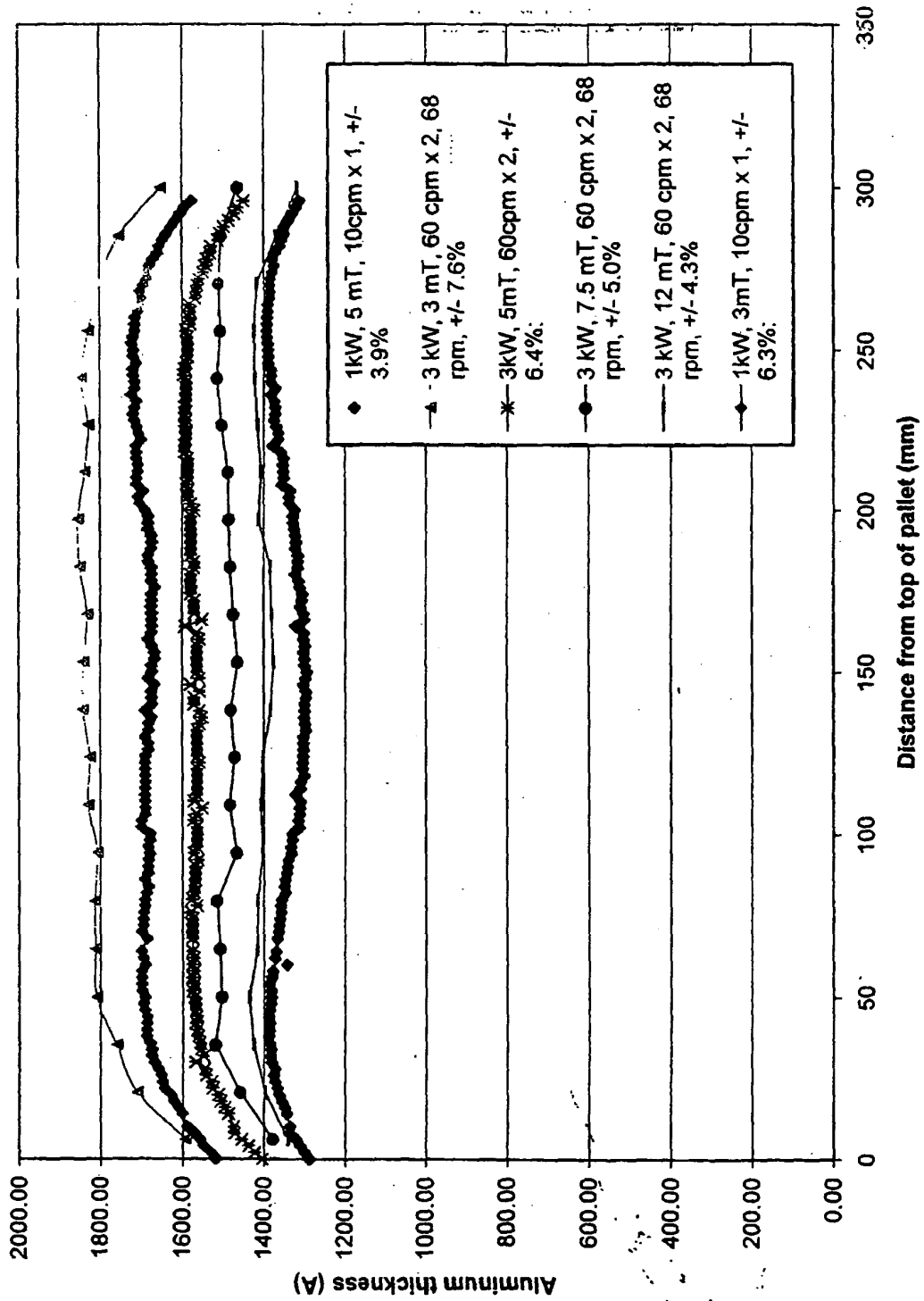


Figure 11.

Aluminum oxide thickness profile top-to-bottom
LMM cathode version 3

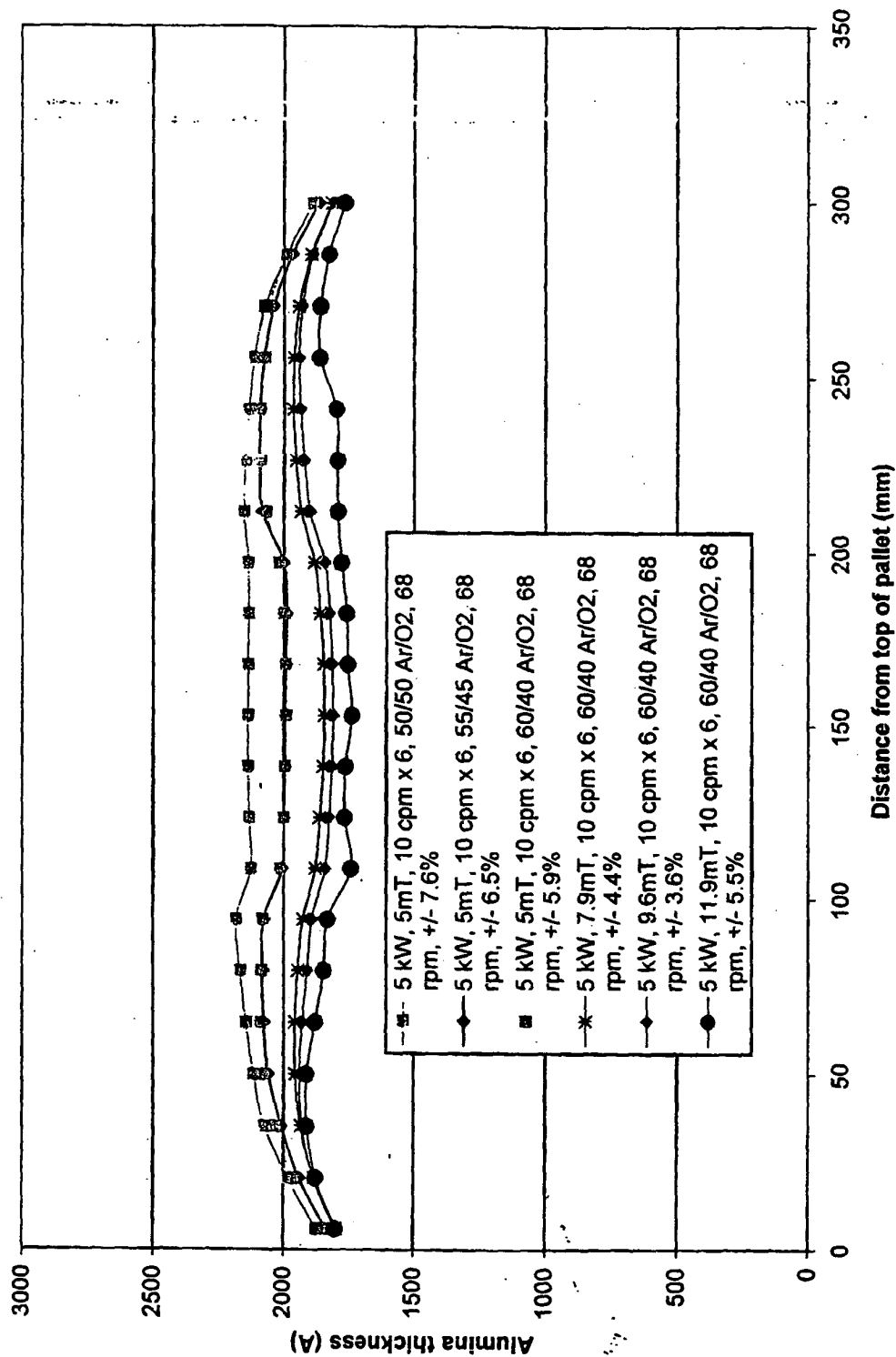


Figure 12.

Aluminum Oxide Hysteresis Loop for LMM Cathode

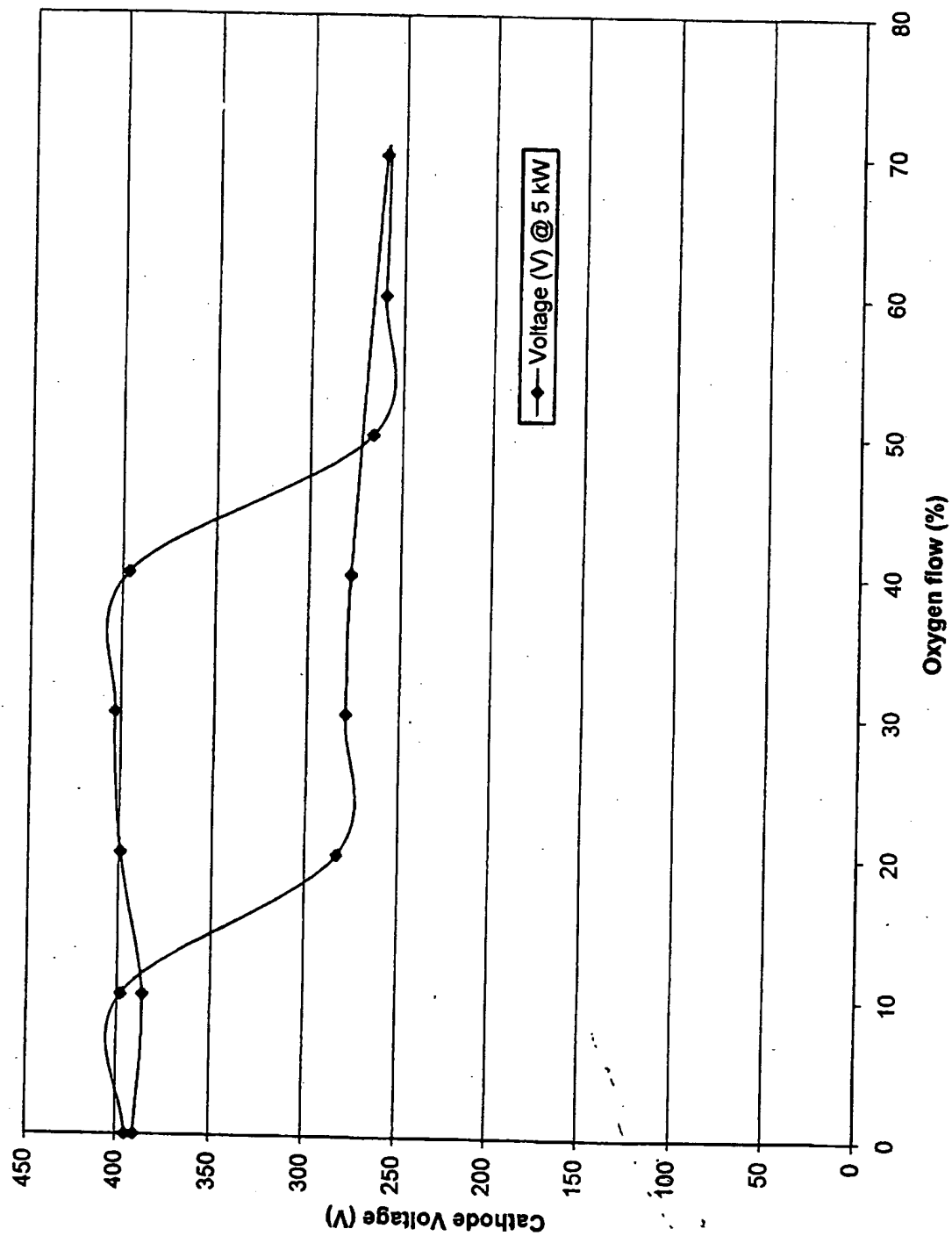


Figure 13.

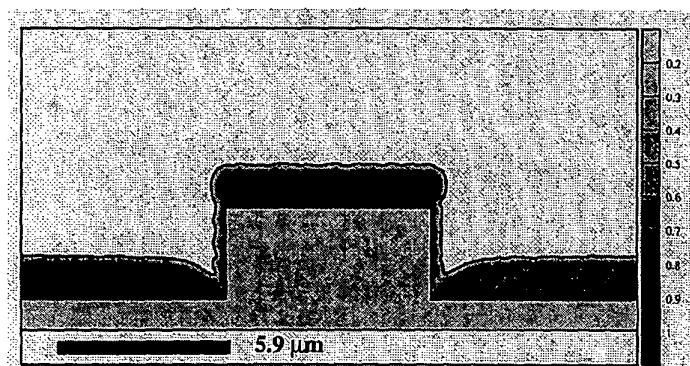


Figure 14 a. Theoretical simulation of oxide film step coverage achieved by prior art.

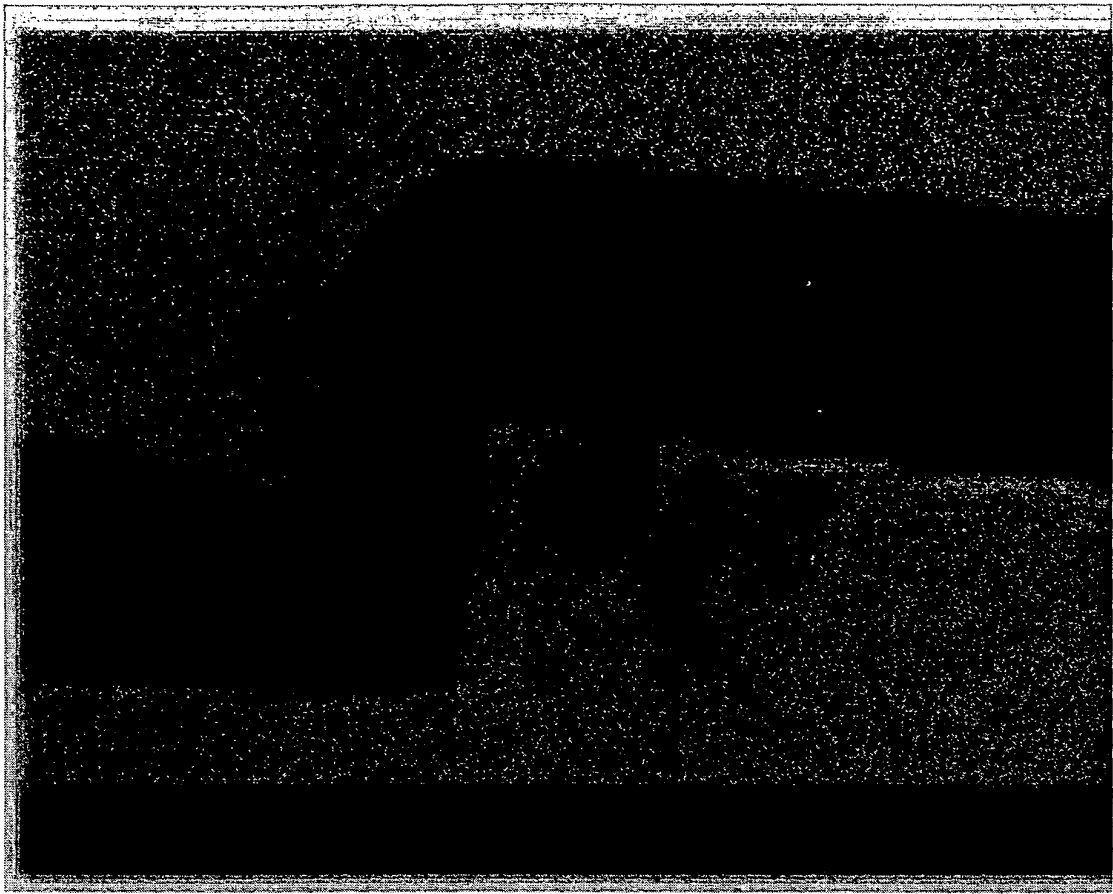


Figure 14b